# PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

### **CONVEYING PARTY DATA**

Name	Execution Date
Christophe Regnier	10/20/2004
Francois Wacquant	10/20/2004

## **RECEIVING PARTY DATA**

Name:	STMicroelectronics SA
Street Address:	29, Boulevard Romain Rolland
City:	Montrouge
State/Country:	FRANCE
Postal Code:	92120

### PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	10871356

## **CORRESPONDENCE DATA**

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PATENT REEL: 015392 FRAME: 0601

### ASSIGNMENT

WHEREAS, we, Christophe Regnier and François Wacquant (hereinafter referred to as ASSIGNORS), having mailing addresses of 6, Chemin du chadeau, Saint Hilaire Du Touvet, France 38660 and 63, rue des Massons, Saint Ismier, France 38330, respectively, are the joint inventors of an invention entitled "METHOD FOR THE SELECTIVE FORMATION OF A SILICIDE ON A WAFER," as described and claimed in the specification for which an application for United States letters patent was filed on June 18, 2004 and assigned Application No. 10/871,356;

WHEREAS, STMicroelectronics SA (hereinafter referred to as ASSIGNEE), a corporation of the country of France having a place of business at 29, Boulevard Romain Rolland, Montrouge, France 92120, is desirous of acquiring the entire right, title and interest in and to the invention and in and to any letters patent that may be granted therefor in the United States and in any and all foreign countries;

NOW, THEREFORE, in exchange for good and valuable consideration, the receipt of which is hereby acknowledged, ASSIGNORS hereby sell, assign and transfer unto said ASSIGNEE the entire right, title and interest in and to said invention, said application and any and all letters patent which may be granted for said invention in the United States of America and its territorial possessions and in any and all foreign countries, and in any and all divisions, reissues and continuations thereof, including the right to file foreign applications directly in the name of ASSIGNEE and to claim priority rights deriving from said United States application to which said foreign applications are entitled by virtue of international convention, treaty or otherwise, said invention, application and all letters patent on said invention to be held and enjoyed by ASSIGNEE and its successors and assigns as fully and entirely as the same would have been held and enjoyed by ASSIGNORS had this assignment, transfer and sale not been made. ASSIGNORS hereby authorize and request the Commissioner of Patents and Trademarks to issue all letters patent on said invention to ASSIGNEE. ASSIGNORS agree to execute all instruments and documents required for the making and prosecution of applications for United States and foreign letters patent on said invention, for litigation regarding letters patent, or for the purpose of protecting title to said invention or letters patent therefor.

> PATENT REEL: 015392 FRAME: 0602

Application No. 10/871,356

Date /10/2005	Christophe Regnier
person who appeared befor	I know or have satisfactory evidence that Christophe Regnier is the me, and said person acknowledged that he signed this instrument his free and voluntary act for the uses and purposes mentioned in the
	Dated
	Signature of _ Witness
	François Wacquant  I know or have satisfactory evidence that François Wacquant is the me, and said person acknowledged that he signed this instrument
	is free and voluntary act for the uses and purposes mentioned in the
	Dated
	Signature of Witness
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PATENT REEL: 015392 FRAME: 0603